



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818
Examiner: David Nhu

In re PATENT APPLICATION of

Applicant : Takashi NAKAMURA et al.)
)
Appl. No. : 09/856,818)
)
Filed : May 25, 2001)
)
For : METHOD OF FORMING SOLID OF A)
 FERRO OR HIGH DIELECTRIC)
 MATERIAL AND METHOD OF)
 MANUFACTURING SEMICONDUCTOR)
 DEVICE EMPLOYING THE SAME)

AMENDMENT

Atty. Dkt. : AI 265NP)

August 27, 2003

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action April 10, 2003, the due date of which has been extended by a Petition for a two-month Extension of Time filed herewith, to expire on September 10, 2003, please amend the above-identified application as follows:

FEE ENCLOSED: \$ 410.
Please charge any further
fee to our Deposit Account
No. 18-0002

RECEIVED
SEP - 3 2003
TECHNOLOGY CENTER 2800